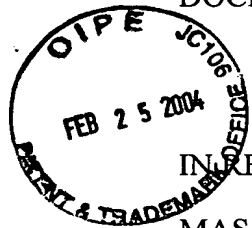


DOCKET NO: 216932US2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

MASAKI YAMADA, ET AL. :

EXAMINER: GREENE, PERSHELLE L.

SERIAL NO: 10/003,114 :

FILED: DECEMBER 6, 2001 :

GROUP ART UNIT: 2826

FOR: SEMICONDUCTOR DEVICE :  
HAVING BURIED CONDUCTIVE LAYER  
AND METHOD OF MANUFACTURING  
THEREOF

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action of September 25, 2003, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 5 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.